Title (en)

METHOD FOR CONTROLLING A PROTECTIVE GAS ATMOSPHERE IN A PROTECTIVE GAS CHAMBER FOR THE TREATMENT OF A METAL STRIP

Title (de)

VERFAHREN ZUM KONTROLLIEREN EINER SCHUTZGASATMOSPHÄRE IN EINER SCHUTZGASKAMMER ZUR BEHANDLUNG EINES METALLBANDES

Title (fr)

PROCÉDÉ POUR LE CONTRÔLE D'UNE ATMOSPHÈRE DE GAZ DE PROTECTION DANS UNE CHAMBRE DE GAZ DE PROTECTION POUR LE TRAITEMENT D'UNE BANDE MÉTALLIQUE

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Application

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Abstract (en)

[origin: WO2012103563A1] The subject matter of said invention is formed by a method for controlling the atmosphere in a protective gas chamber (2) for the continuous treatment of metal strips (3). Here, the metal strip (3) is guided into and out of the protective gas chamber (2) via locks (4). At least one lock (4) has at least two sealing elements (5, 6) for the metal strip (3) which runs through it, with the result that a sealed chamber (7) is formed between the two sealing elements (5, 6). According to the invention, the gas pressure (P2, PD) is measured in the protective gas chamber (2) and in the sealed chamber (7) of the lock (4) and the pressure (PD) in the sealed chamber (7) is regulated, to be precise in such a way that, during operation, the differential pressure between the protective gas chamber (2) and the sealed chamber (7) is kept as far as possible to an optimum value.

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